Initial Considerations for EIC detector EMCal

(from the viewpoint of data analyzer)

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EIC-YR-Detector-Calorimetry Meeting
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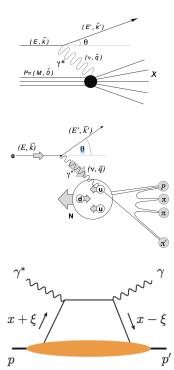
EMCal at EIC

Electron/photon PID, energy, position: Coverage, resolutions, granularity, projectivity

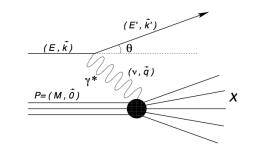
Inclusive DIS: scattered electron

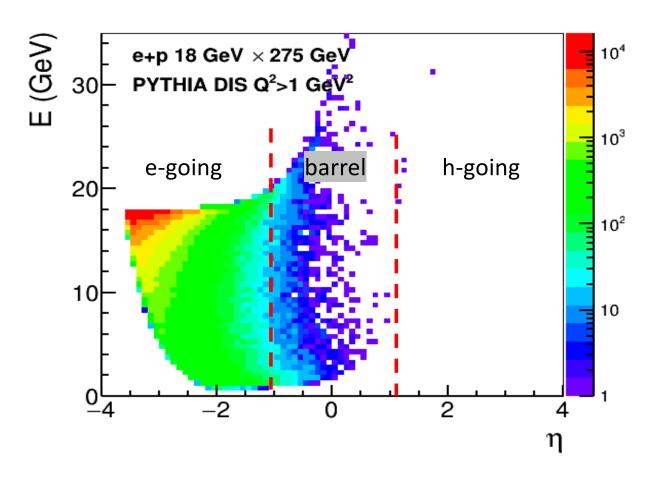
Semi-Inclusive DIS: π 0

Exclusive DIS: DVCS photons, $J/\psi \rightarrow ee$ etc.



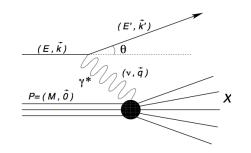
Inclusive DIS: scattered electron

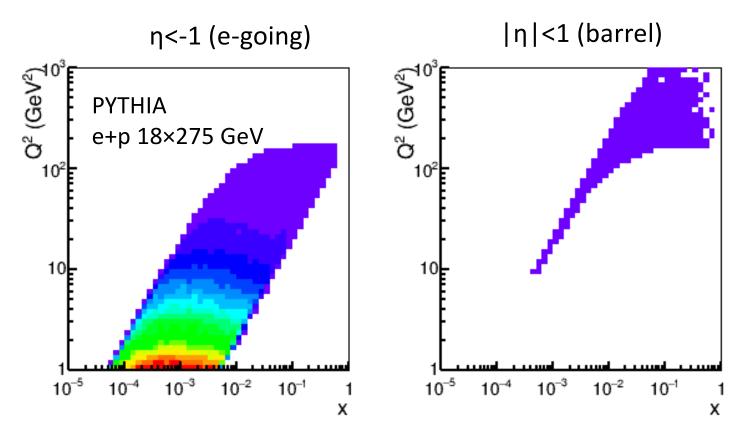




Mostly scattered in backward (e-going) and barrel Electron energy varies from 0 to e-beam energy in backward (e-going), And to higher energy in barrel and h-going region

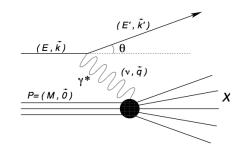
Inclusive DIS: Q² vs x

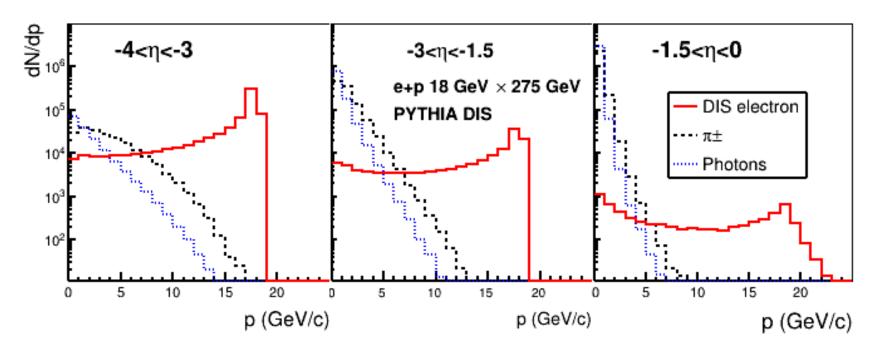




High Q² events correspond to scattering in barrel (and h-going) region

Inclusive DIS: background



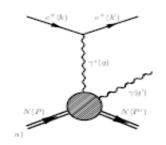


Clean measurements at higher momenta

Huge background at lower momenta

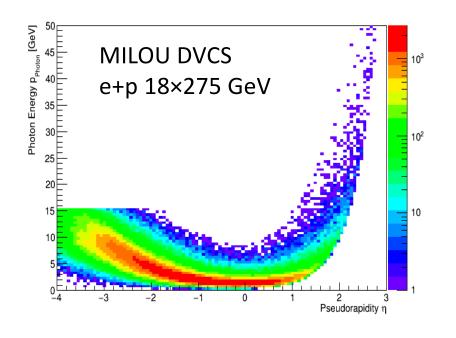
Down to what momenta should we provide reliable ePID?

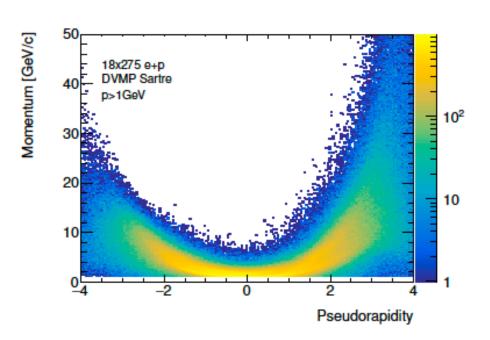
Exclusive DIS: DVCS and DVMP



DVCS photon kinematics



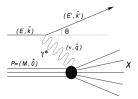




Wide rapidity coverage is crucial

Resolutions

$$Q^{2} = 4EE'\sin^{2}\left(\frac{\theta}{2}\right) \qquad y = 1 - \frac{E'}{E}\cos^{2}\left(\frac{\theta}{2}\right) \qquad x = \frac{Q^{2}}{sy}$$



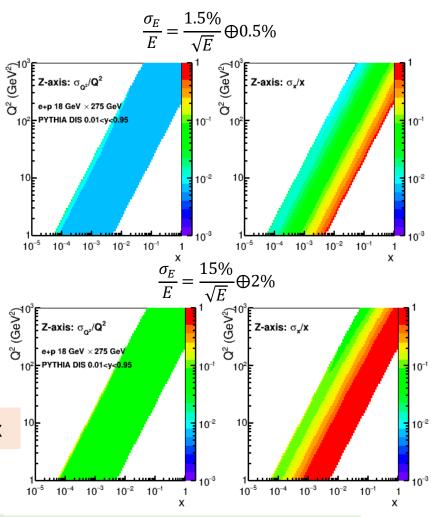
Resolutions for (x,Q^2)

For perfect angle measurements:

$$\frac{\sigma_{Q^2}}{Q^2} = \frac{\sigma_{E'}}{E'} \qquad \frac{\sigma_x}{x} = \frac{1}{y} \frac{\sigma_{E'}}{E'}$$

Defines the precision of unfolding technique to correct for smearing due to detector effects
Minimal effect from position resolution

Better resolution => wider kin. coverage in x



Good resolution is particularly important in backward (e-going) direction:

Due to a general degradation of tracking performance close to the beam line

Higher Q² kinematics (in barrel and h-going direction) can be extracted from final state hadron measurements (Jacquet-Blondel approach)

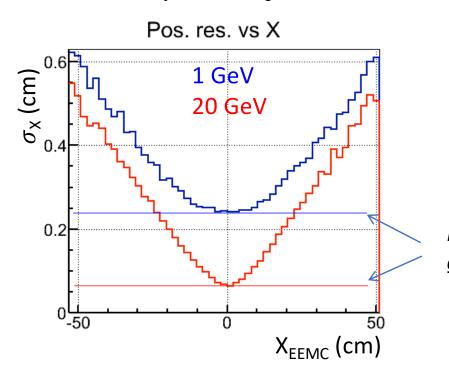
Projectivity

Non-projectivity:

Deteriorates position resolution

Deteriorates shower profile evaluation (for e/ γ identification and π^0/γ discrimination)

GEANT4: Crystal endcap EMCal at ~1.2m



$$\sigma_{X}(E,\theta_{X}) = \sigma_{X}(E,0^{0}) \oplus d\sin(\theta_{X})$$
For projective "Non-projectivity" term (from long. shower fluct.) $d\sim X_{0}$

For projective geometry

Position resolution is dominated by "non-projectivity" term (for this nonprojective EMCal)

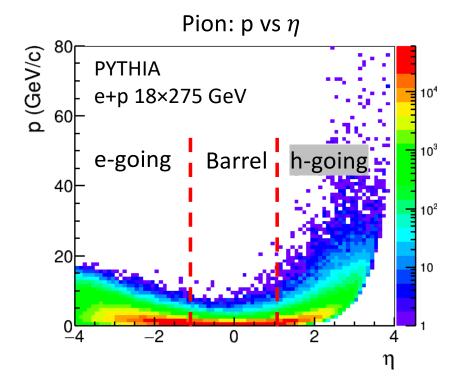
Granularity and $\pi 0/\gamma$ discrimination in EMCal (alone)

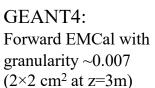
$$\theta_{min}^{\pi 0 \to \gamma \gamma} \approx \frac{2m_{\pi 0}}{E_{\pi 0}}$$

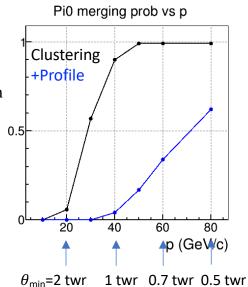
$\pi 0 \rightarrow \gamma \gamma$:

"Simple" clustering distinguishes two photons if they are separated by 1.5–2 tower distance in EMCal

Shower profile analysis distinguishes merged photons from single one if they are separated by 0.5–1 towers.







Pion momenta are limited by $\sim 10 \ (\sim 15) \ GeV/c$ in barrel (e-going) => Granularity of 0.03 (0.02) looks sufficient

< 0.01 granularity may be needed for h-going